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Well-known Washington Environmental Editor and Reporter Joins Nanotech Project

Inside Washington's Colin Finan Takes on Communications and Policy Role

Washington, DC—Colin Finan, former Managing Editor of *Environmental Policy Alert* and Associate Editor of *InsideEPA.com*, is the new Public Affairs and Policy Associate at the Wilson Center's **Project on Emerging Nanotechnologies**. As a journalist covering environment and energy issues, Finan regularly reported on nanotechnology regulatory and research topics for Inside Washington Publishers (IWP). With over 70 editors and reporters, IWP is a prominent source of behind-the-scenes coverage of federal policy in environment, defense, health care, trade and energy matters.

Finan is a graduate of the University of Wisconsin-Madison, where he was Managing Editor of the university's independent daily student newspaper. In addition to IWP, he worked as a writer and reporter for various newspapers and magazines in New Mexico, New York, and Illinois.

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The **Project on Emerging Nanotechnologies** is an initiative launched by the **Woodrow Wilson International Center for Scholars** and **The Pew Charitable Trusts** in 2005. It is dedicated to helping business, government and the public anticipate and manage possible health and environmental implications of nanotechnology.

About Nanotechnology

Nanotechnology is the ability to measure, see, manipulate and manufacture things usually between 1 and 100 nanometers. A nanometer is one billionth of a meter; a human hair is roughly 100,000 nanometers wide. Experts believe nanotechnology will lead to the Next Industrial Revolution. Last year, \$50 billion in manufactured goods incorporated nanotechnology. By 2014, Lux Research projects that \$2.6 trillion in global manufactured goods will incorporate nanotech, or about 15 percent of total global output.

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